

Technical specifications	
SITRANS LR580	
Mode of operation	
Recommended measuring range	Beam angle 3°: 120 m (394 ft)
Medium conditions	
Process temperature	PEEK/FKM: -40 ... +150 °C (-40 ... +302 °F) PEEK/FKM, thermal extension: -40 ... +200 °C (-40 ... +392 °F) PEEK/FFKM, thermal extension: -15 ... +250 °C (-4 ... +392 °F)
Process pressure	-1 ... 3 bar max.
Design	
Flange material	316/316L
Wetted materials	
Antenna lens	PEEK
Antenna seal	FKM/FFKM (Perlast G75B)
Process connections	DN80 PN16, flat face DN100 PN16, flat face DN150 PN16, flat face 3" 150 lb, flat face 4" 150 lb, flat face 6" 150 lb, flat face DN80 10K, flat face, JIS DN100 10K, flat face, JIS DN150 10K, flat face, JIS Aiming flange universal DN100/4" Aiming flange universal